



Attorney Docket # 5300-17

Patent

ALB  
11/20/02  
#5

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Neil S CASA

Serial No.: 10/007,618

Filed: November 07, 2001

For: System And Method For Inhibiting Motion Of  
Semiconductor Wafers In A Variable-Pressure  
Chamber

Examiner:

Group Art:

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Please also change the attorney docket number from to **5300-17**. Thank you.

Respectfully submitted,  
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Dated: November 8, 2002